

## TechnoShield Award of the Year 2008 APPLICATION FORM

Last date to send in your filled application forms: **February 20, 2008**

- Please read all the instructions at [www.isaonline.org/technovation](http://www.isaonline.org/technovation) before filling in the application form.
- Please complete the form and send it in hard copy.
- Soft copy of all the documents with application form should be sent on a CD.
- Please ensure that the required details are properly attached)
- Please fill the form in BLOCK letters.

Name of the Institute/Department/Lab.

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.....

AICTE recognition as a degree awarding Institute (Please give reference number):

.....  
.....

Address for correspondence:

Postal address

.....  
.....

Email

Telephone (Office/Institute)

(Residence)

Facsimile

.....  
.....

Laboratory details (Please attach relevant documents as Annexure A):

- Introduction up to 500 words on the lab describing its activities
- R & D areas of focus
- Staff members in the laboratory/dept/university with profile of key researchers

Name and contact details of 2 referees:

1. Name:

Designation:

.....  
Postal address:

.....  
Email:

Telephone (Office/Institute)

.....  
.....

2. Name:

Designation:

.....  
Postal address:

.....  
Email:

Telephone (Office/Institute)

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Research & Development work done in the laboratory in the last 5 years (in about 500 words). Specific reference is to be made to research papers published and patents taken in this context. Impact of the contributions in the field concerned, basic or applied (All relevant documents to be attached as Annexure B)

Books, reviews, papers, etc. where research work of the immediate past 5 years has been referred/cited. Give citation index of the contribution as follows (All relevant documents to be attached as Annexure C as per format given below):

**PAPER**

Name of the author	Name of journal	Year of publication	Volume	Page no.

**BOOK**

Name of the author who has cited	Year of publication	Publisher	Page no.

Names of the industries in which the technology has been used or could be used:

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Please provide details of past achievements and awards in the following format:

Name of the body	Nature of the award	Year of the award
.....	.....	.....
.....	.....	.....
.....	.....	.....
.....	.....	.....

Number of doctoral students who have graduated in the immediate past 5 years, along with the area of research:

.....

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## Enclosures required

- List of applicant's significant publications (one set of reprints to be enclosed).
- Complete list of publications in standard refereed journals.\*
- List of papers published in conferences/symposia/seminars etc.
- List of applicant's books or book chapter published.
- List of patents held.
- Information about patents applied for (if any).
- Information of relevance such as the number of doctoral students guided, with the area.
- Additional Annexure may be used for any other information.

\* Listing of publications in journals/conferences or books should be as follows:

Names of all the authors as they appear in each paper	Title of the paper	Name of the journal, volume, year and page

## Certified that information given in the above application form is correct

.....  
Place

.....  
Principal/Director's signature  
with institute seal

.....  
Date

.....  
Only completed application forms with all supporting documents will be considered

END OF APPLICATION FORM

For further clarification contact [technovation@isaonline.org](mailto:technovation@isaonline.org) or log on to [www.isaonline.org/technovation](http://www.isaonline.org/technovation)

(Please tick ✓ relevant boxes)

**Checklist:** Annexures **A**  **B**  **C**  **Others**  **CD**



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